

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-163003	Application No. 09/898,986
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.989)		Applicant Yamazaki, et al.	
		Filing Date July 3, 2001	Group Art Unit 2813

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
<i>[Signature]</i>	AA	5,898,204	4/1999	Watanabe			
	AB	5,998,854	12/1999	Morishita et al.			
	AC	6,180,957	1/2001	Miyasaka et al.			
	AD	5,550,397	08/27/96	Lifshitz et al.			
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<i>[Signature]</i>	AH	5,726,459	03/10/98	Hsu et al.			
	AI						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
<i>[Signature]</i>	AJ	04-206971	07/28/92	JAPAN				
	AK	04-286339	10/12/92	JAPAN				
	AL	06-232059	08/19/94	JAPAN				
	AM	07-169974	07/04/95	JAPAN				
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<i>[Signature]</i>	AO	07/321339	12/08/95	JAPAN				

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
<i>[Signature]</i>	AP	Wang et al., Enhanced Performance of Accumulation Mode 0.5 μ m CMOS/SOI Operated at 300 K and 85 K, IEEE, IEDM 91, pp. 679-682.
	AQ	Fossum et al., "Anomalous Leadage Current in LPCVD Polysilicon MOSFET's", September 1995, IEEE Transactions on Electron Devices, Vol. ED-32, No. 9; pp. 1878-1884.
	AR	Qian et al., "Inversion/Accumulation-Mode Polysilicon Thin-Film Transistors: Characterization and Unified Modeling", September 1988, IEEE Transactions on Electron Devices, Vol. 35, pp. 1501-1509.
<i>[Signature]</i>	AS	Malhi et al., "p-Channel MOSFET's in LPCVD Polysilicon", October 1983, IEEE Electron Device Letters, Vol. EDL-4, No. 10, pp. 369-371.

Examiner Signature <i>[Signature]</i>	Date Considered 10/28/05
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	